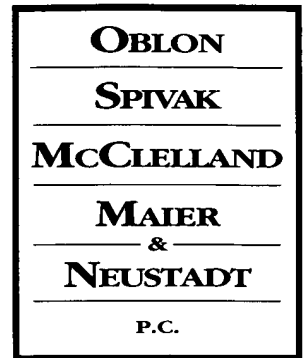




JFW



Docket No.: 250507US2DIV

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/807,119
Applicants: Yoshiki IGARASHI, et al.
Filing Date: March 24, 2004
For: OXIDE FILM ETCHING METHOD
Group Art Unit: 2818
Examiner: Hoang, Q.D.

ATTORNEYS AT LAW
STEVEN P. WEIHRUCH
(703) 413-3000
SWEIHRUCH@OBLON.COM
RAYMOND F. CARDILLO, JR.
(703) 413-3000
RCARDILLO@OBLON.COM

SIR:

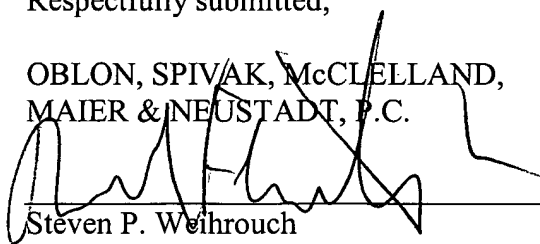
Attached hereto for filing are the following papers:

REQUEST FOR RECONSIDERATION

Our check in the amount of - 0 - is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Steven P. Weihrouch

Registration No. 32,829

Attorney of Record

Raymond F. Cardillo, Jr.
Registration No. 40,440

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)



DOCKET NO: 250507US2DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
YOSHIKI IGARASHI, ET AL. : EXAMINER: HOANG, Q. D.
SERIAL NO: 10/807,119 :
FILED: MARCH 24, 2004 : GROUP ART UNIT: 2818
FOR: OXIDE FILM ETCHING METHOD :

REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated April 19, 2005, please note the following
remarks:

Remarks/Arguments begin on page 2 of this paper.